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Attorney Docket No. 55987 (71896)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Mitsuhiro Kawazu

U.S.S.N. 09/887,967

Art Unit: 1756

FILED: 6/22/01

Examiner: J. McPherson

FOR: METHOD OF PREPARING ARTICLE COVERED WITH LIGHT
ABSORPTION PATTERN FILM AND ARTICLE COVERED WITH LIGHT
ABSORPTION PATTERN FILM

CERTIFICATE OF MAILING

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 1, 2003

By: Eileen M Woodbury
Eileen Woodbury

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE TO OFFICE ACTION

The following is in response to the Office Action mailed May 7, 2003, in the above referenced application.

Applicants believe that no extension of time is required since this response is being filed before the expiration of the specified time period. Applicants, however, conditionally petition for an extension of time to provide for the possibility that such a petition has been inadvertently overlooked and is required. As provided below charge Deposit Account No. **04-1105** for any required fee.

Please amend the application as follows.